

Applicant: LYU, Yi Yeol et al

COPY

Application No.:

Group:

Filed: March 27, 2002

Examiner:

For: SILOXANE-BASED RESIN AND METHOD FOR FORMING INSULATING FILM
BETWEEN INTERCONNECT LAYERS IN SEMICONDUCTOR DEVICES BY
USING THE SAME

LETTER

Honorable Commissioner of Patents
and Trademarks
Washington, D.C. 20231

March 27, 2002
3811-0109P

Sir:

Under the provisions of 35 USC 119 and 37 CFR 1.55(a), the applicant hereby claims the right of priority based on the following application(s):

<u>Country</u>	<u>Application No.</u>	<u>Filed</u>
REPUBLIC OF KOREA	2001-15884	03/27/01
REPUBLIC OF KOREA	2001-56798	09/14/01
United States of America	09/895,158	07/02/01

A certified copy of the above-noted application(s) is(are) attached hereto.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. 1.16 or under 37 C.F.R. 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By: _____

Attachment
(703) 205-8000
/nv

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3811-0109P
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1 of 2

대한민국 특허청

KOREAN INTELLECTUAL PROPERTY OFFICE

별첨 사본은 아래 출원의 원본과 동일함을 증명함.

This is to certify that the following application annexed hereto
is a true copy from the records of the Korean Intellectual
Property Office.

출원번호 : 특허출원 2001년 제 15884 호
Application Number PATENT-2001-0015884

출원년월일 : 2001년 03월 27일
Date of Application MAR 27, 2001

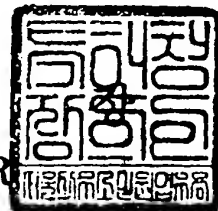
출원인 : 삼성전자 주식회사
Applicant(s) SAMSUNG ELECTRONICS CO., LTD.



2002 년 01 월 09 일

특 허 청

COMMISSIONER



3811-01092
LYU, Yi Yeol et al
March 27, 2005
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This is to certify that the following application annexed hereto
is a true copy from the records of the Korean Intellectual
Property Office.

출원번호 : 특허출원 2001년 제 56798 호
Application Number PATENT-2001-0056798

출원년월일 : 2001년 09월 14일
Date of Application SEP 14, 2001

출원인 : 삼성전자 주식회사
Applicant(s) SAMSUNG ELECTRONICS CO., LTD.



2002 년 01 월 09 일

특 허 청

COMMISSIONER

